

**Search Notes**

Application/Control No.

10/802,053

Examiner

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Applicant(s)/Patent under  
Reexamination

CHA, CHI-HO

Art Unit

2611

**SEARCHED**

Class	Subclass	Date	Examiner
375	260	4/24/2007	JP
	368	4/24/2007	JP
	369	4/24/2007	JP
	147-153	4/24/2007	JP

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East USPAT/USPGPUB	4/24/2007	JP
Inventor Name Search EAST/EDAN	4/24/2007	JP